

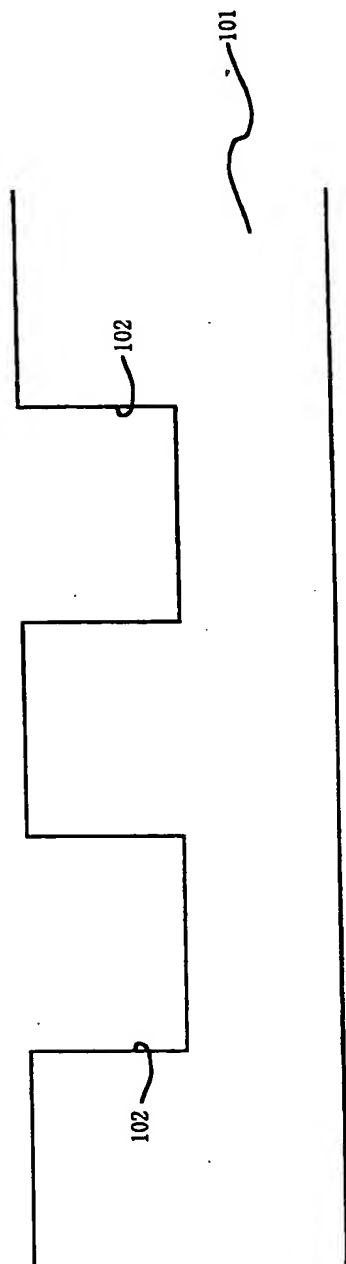
WIRING STRUCTURE OF SEMICONDUCTOR DEVICE AND METHOD
OF MANUFACTURING THE SAME

Application No. [NEW] - Attorney Docket No. OKI.612

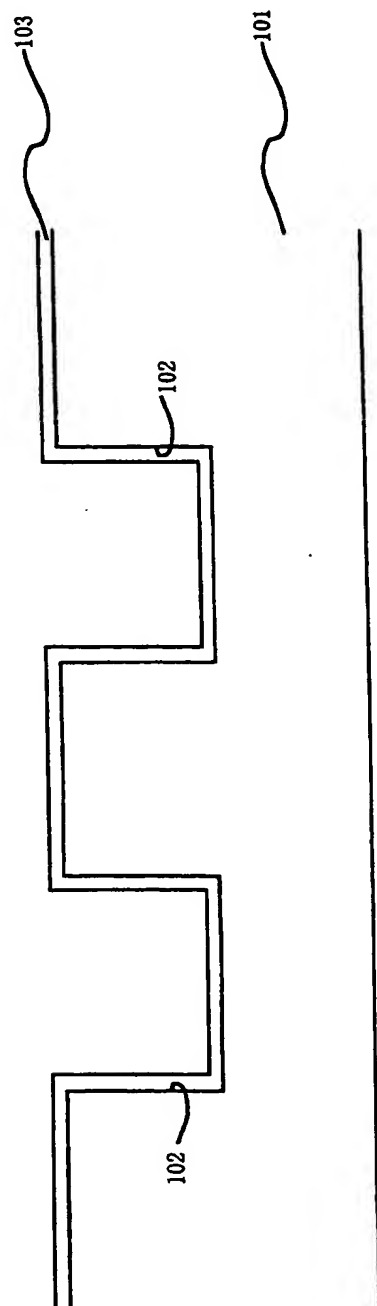
Inventor: Kazuhide ABE

F-03ED0103

FIG. 1



Inventor: Kazuhide ABE



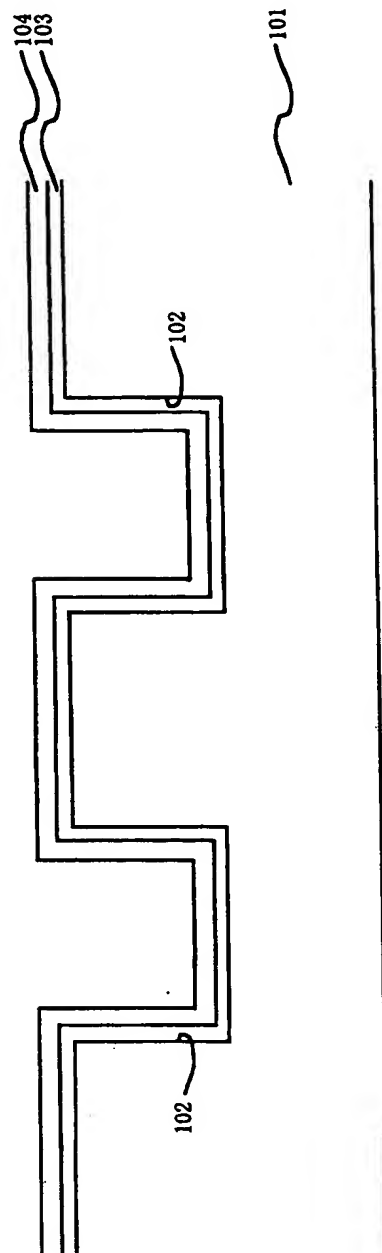
WIRING STRUCTURE OF SEMICONDUCTOR DEVICE AND METHOD
OF MANUFACTURING THE SAME

Application No. [NEW] - Attorney Docket No. OKI.612

Inventor: Kazuhide ABE

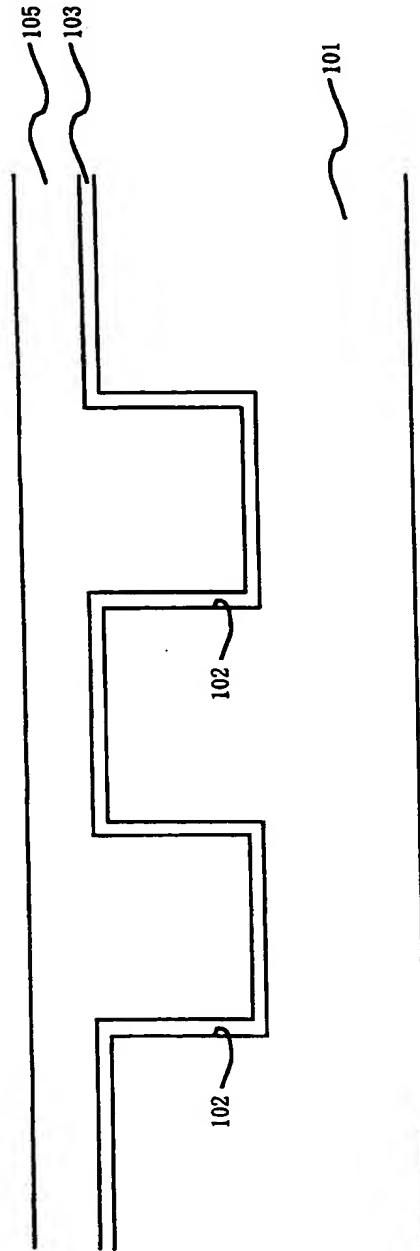
F-03ED0103

FIG. 3



Application No. [NEW] - Attorney Docket No. OKI.612
Inventor: Kazuhide ABE

Fig. 4



Inventor: Kazuhide ABE

FIG. 5

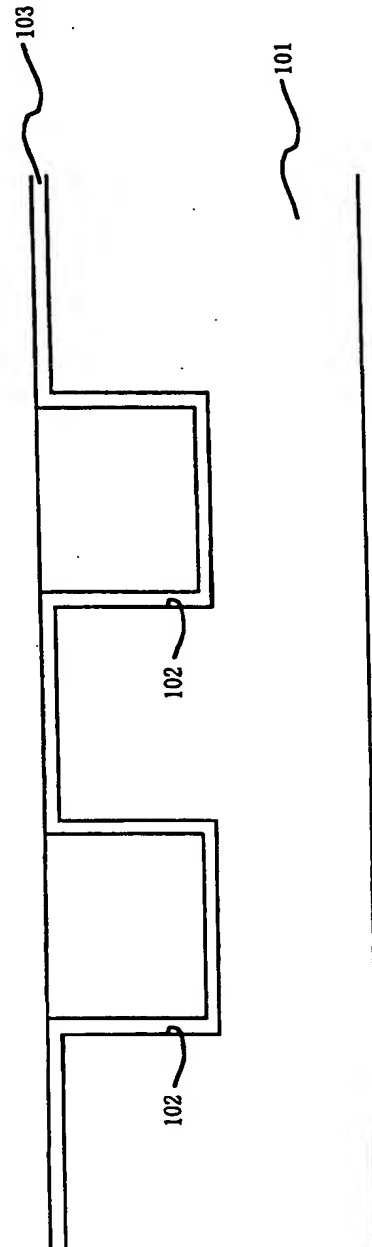


FIG. 6

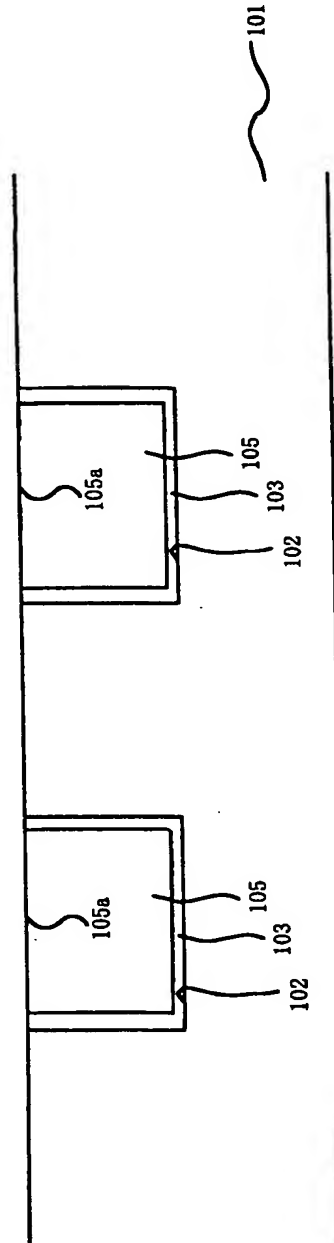


FIG. 7

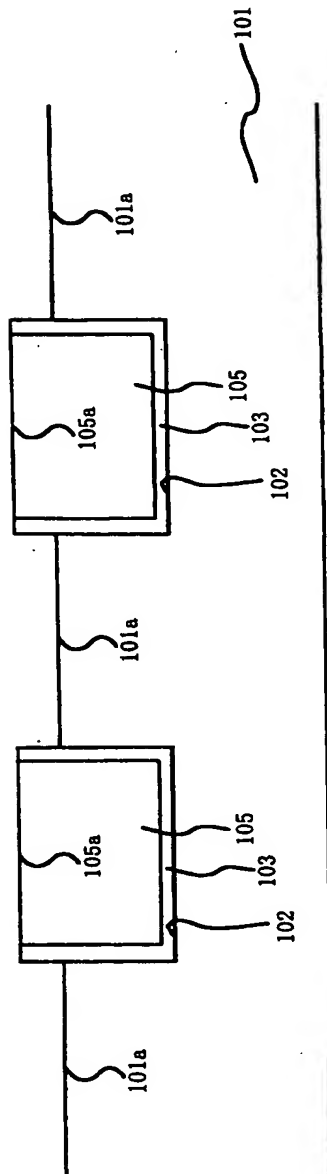
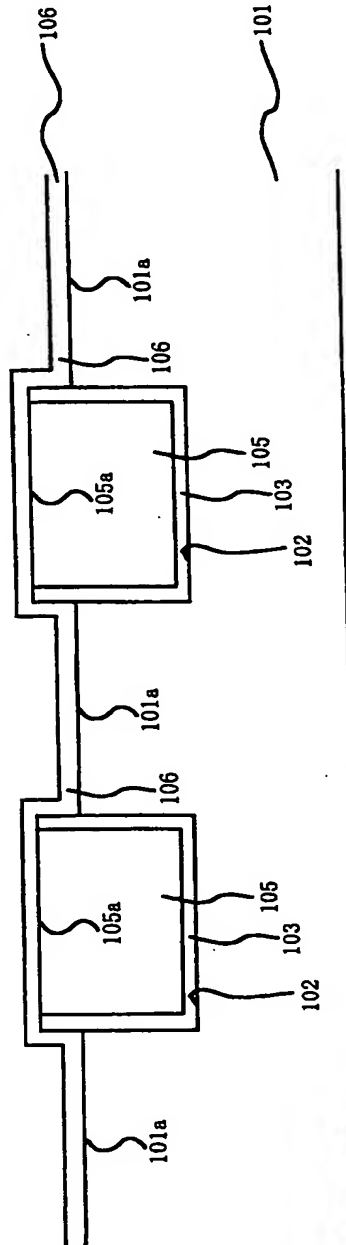


FIG. 8



Inventor: Kazuhide ABE

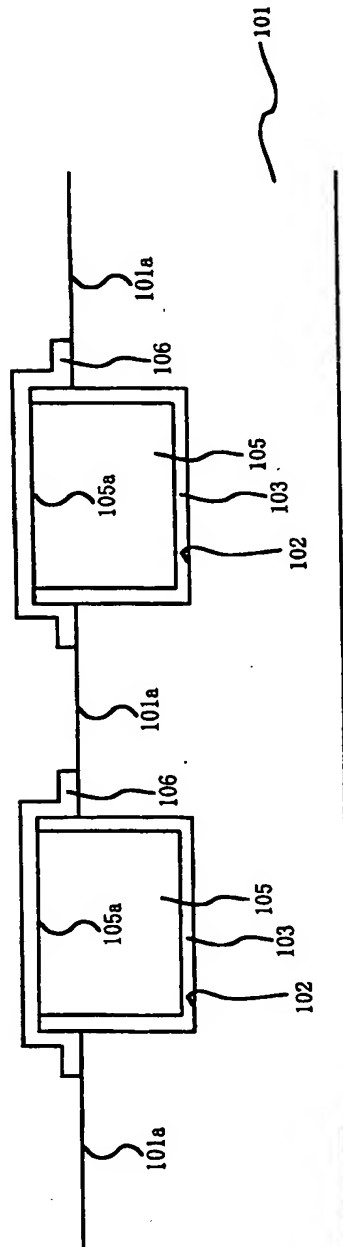


FIG. 10

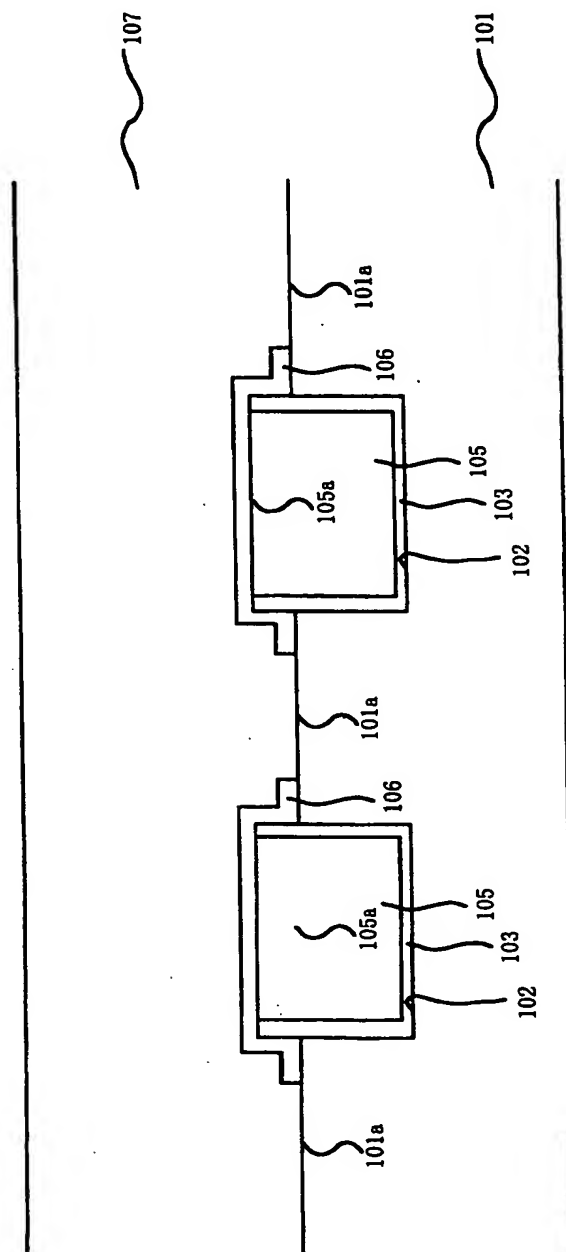


FIG. 11

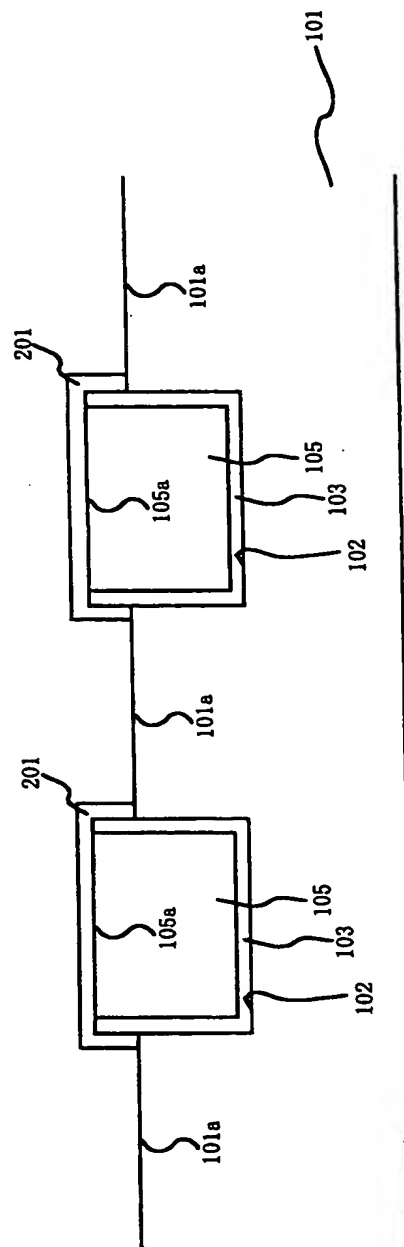


FIG. 12

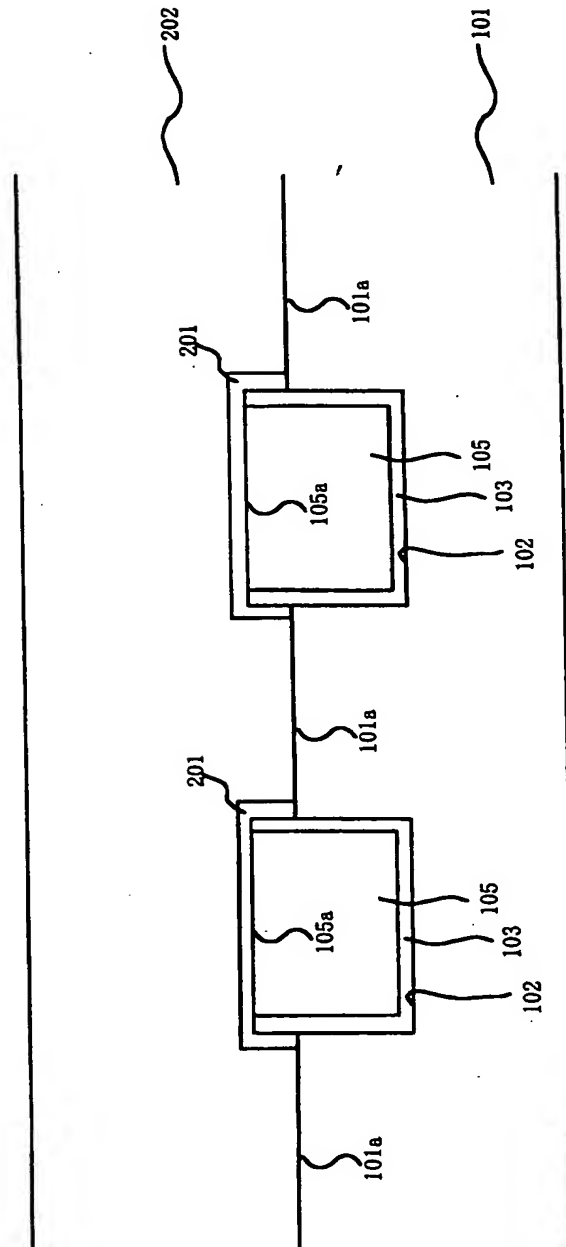


FIG. 13

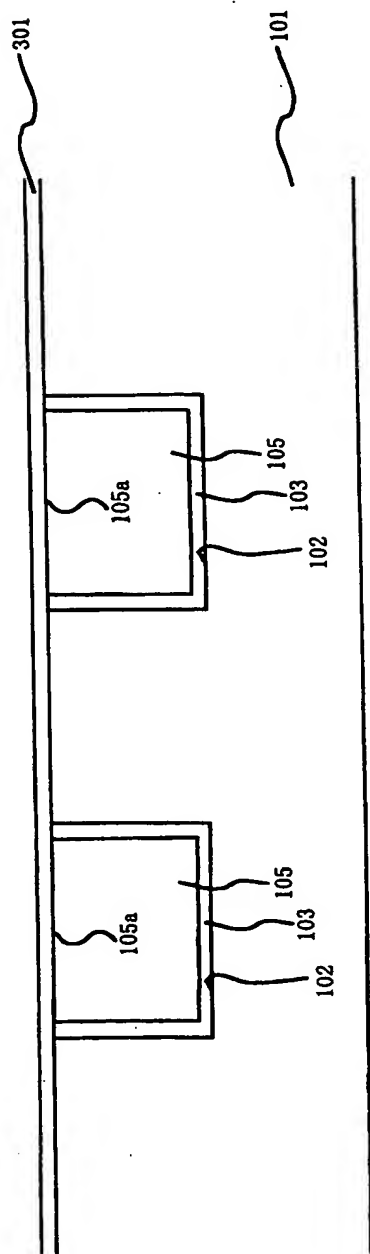
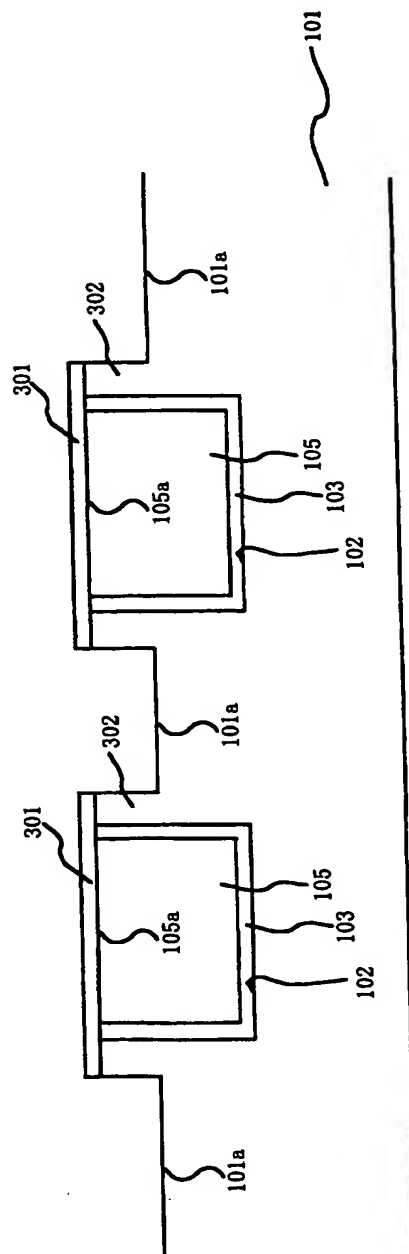


FIG. 14



Inventor: Kazuhide ABE

FIG. 15

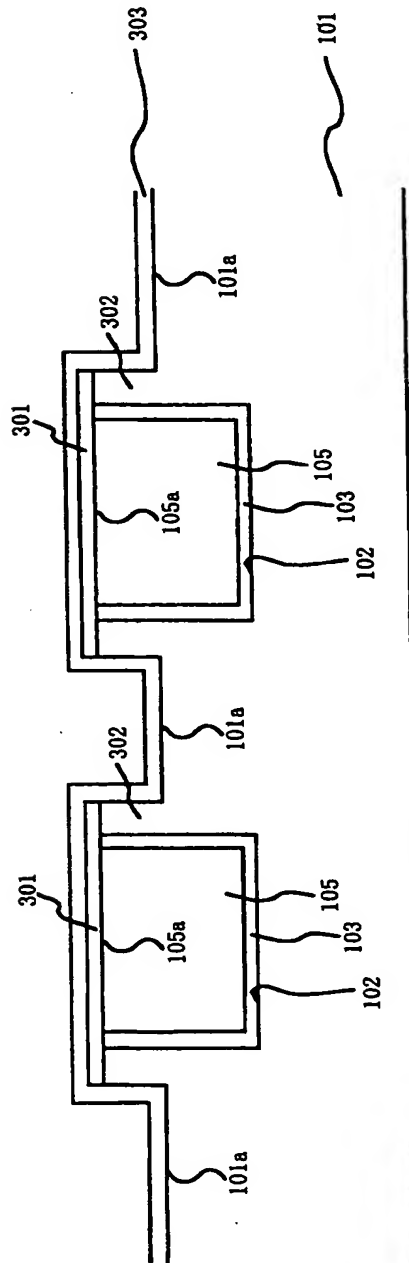


FIG. 16

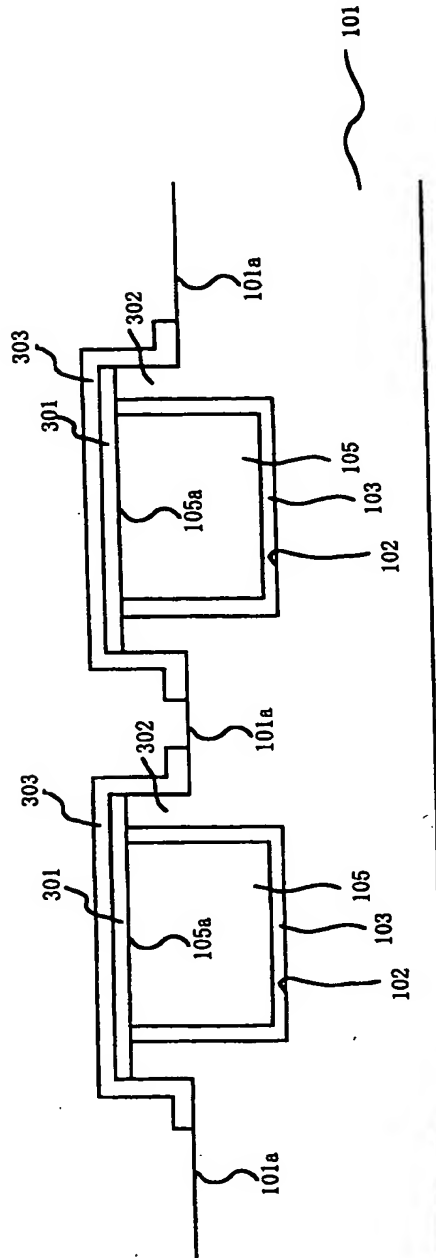
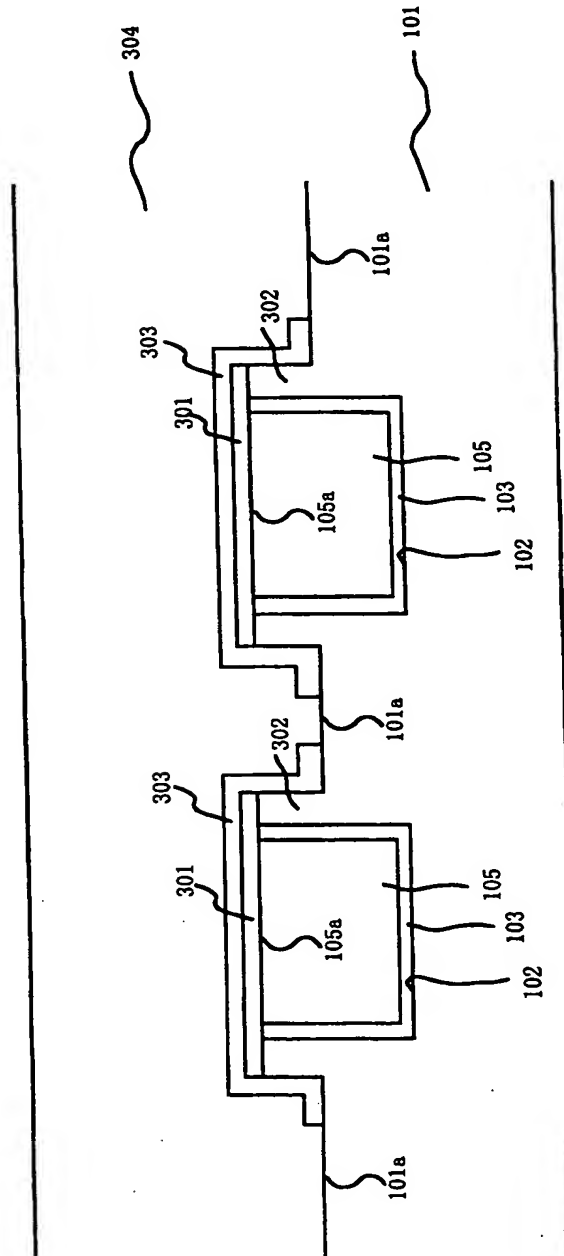


FIG. 17



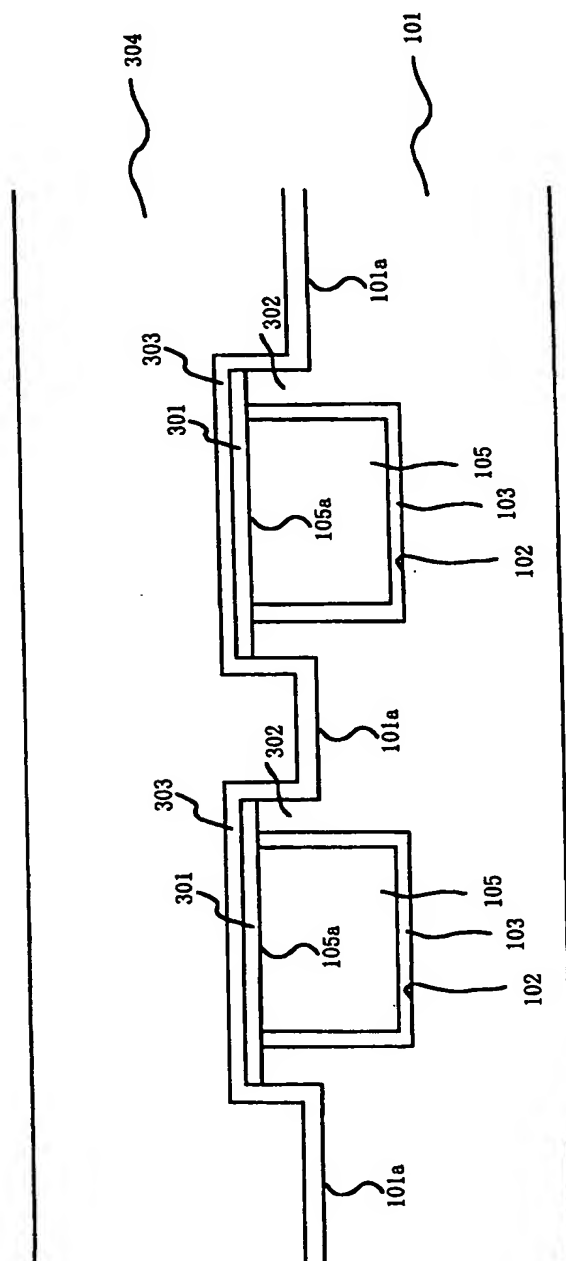


FIG. 19

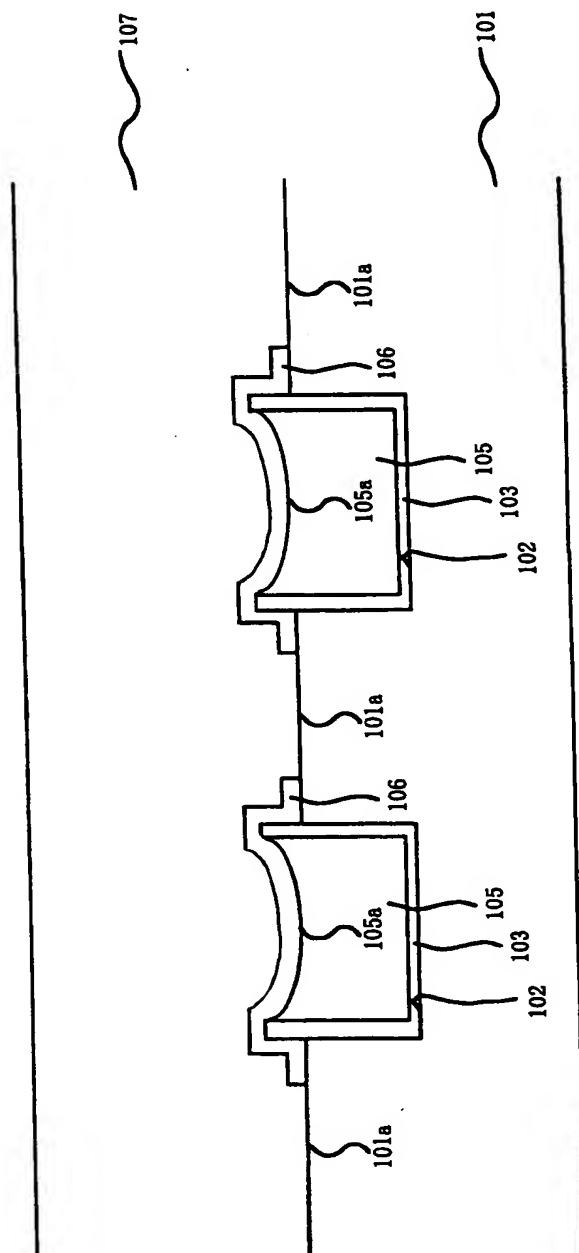


FIG. 20

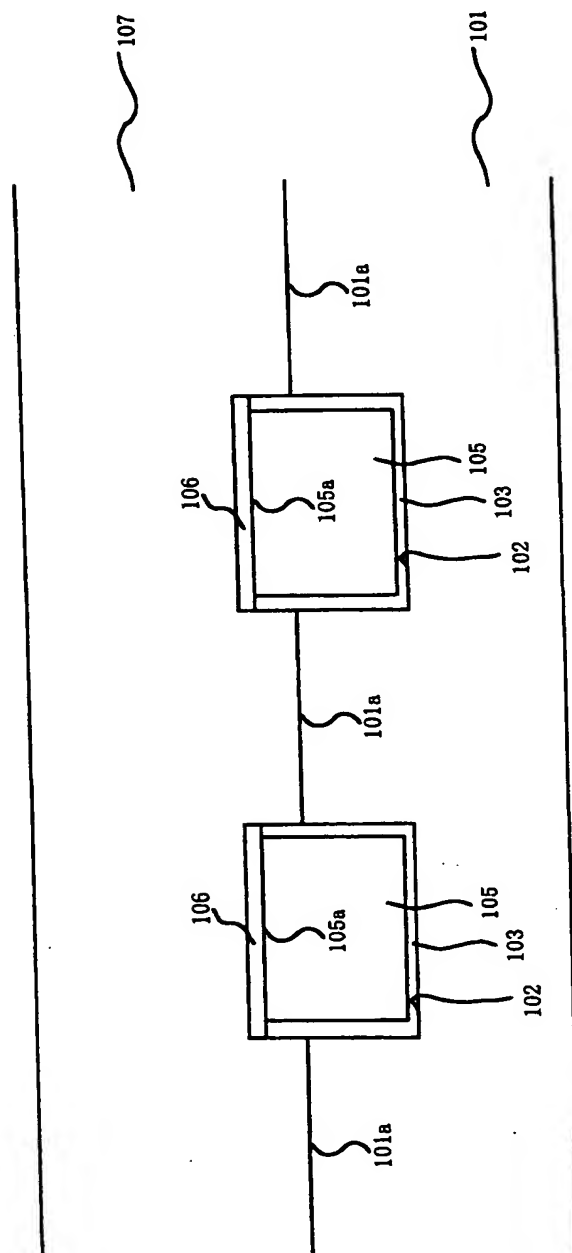


FIG. 21

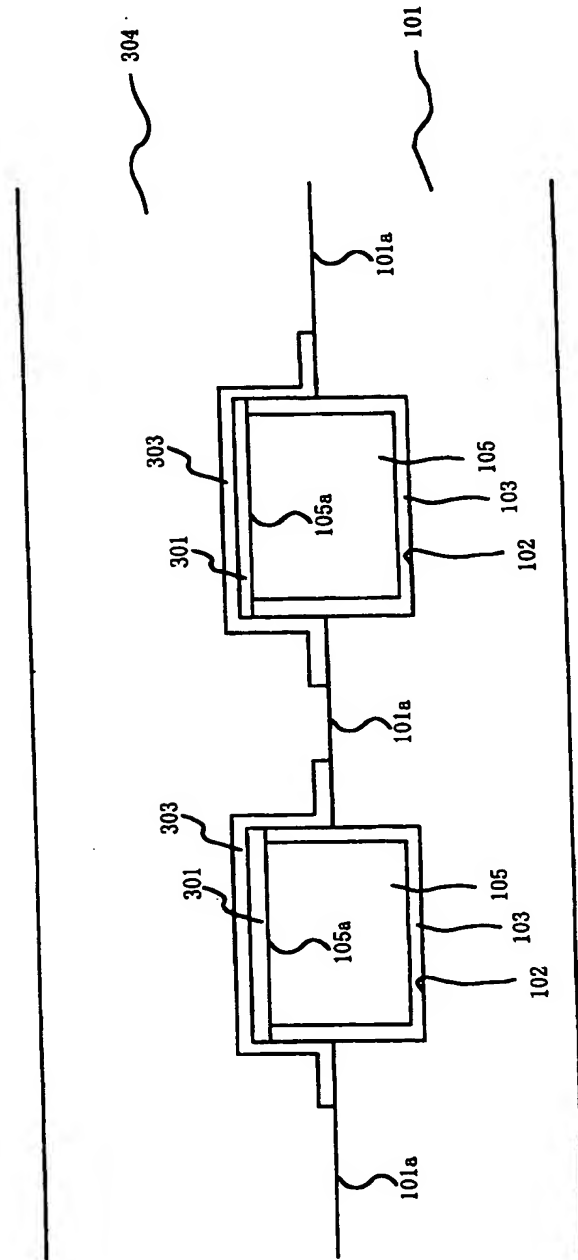


FIG. 22

